



Docket No.: 060188-0658

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Masashi HAMANAKA, et al.	:	Confirmation Number: 8488
Application No.: 10/671,502	:	Group Art Unit: 3723
Filed: September 29, 2003	:	Examiner: RACHUBA, MAURINA T

For: POLISHING METHOD FOR SEMICONDUCTOR DEVICE, METHOD FOR
FABRICATING SEMICONDUCTOR DEVICE AND POLISHING SYSTEM

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated July 15, 2005, now due to expire October 15, 2005, be extended for one (1) month and set to expire on November 15, 2005.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

11/16/2005 SZEWDIE1 00000175 500417 10671502
01 FC:1251 120.00 DA

Respectfully submitted,

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Date: November 15, 2005

**Please recognize our Customer No. 20277
as our correspondence address.**